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U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10029158	12/21/2001	451	285	3723	RACHOB

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**CONTINUING DATA VERIFIED:

THIS APPLICATION IS A CIP OF 09/628,563 07/31/2000
AND CLAIMS BENEFIT OF 60/259,016 12/29/2000

** FOREIGN APPLICATIONS VERIFIED:

PCT/US01/41513 07/31/2001

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed 35 USC 119 conditions met Verified and Acknowledged Examiners's initials		<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no	ATTORNEY DOCKET NO A-69175-1/MSS
TITLE : Apparatus and method for chemical mechanical polishing of substrates U.S.DEP.T. OF COMM./PAT. & TM-PTO-436L(Rev. 12-94)			

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G
ISSUE FEE		DRAWING		
Amount Due	Date Paid	Sheets Draw.	Figs. Draw.	Print Fig.
TERMINAL		Primary Examiner		
DISCLAIMER		Application Examiner		
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